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Filing Date **FEBRUARY 24, 2004** First Named Inventor **HUANG** Group Art Unit UNKNOWN **Examiner Name** UNKNOWN

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		OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS	
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
ms		Chapman et al., Polymeric Thin films That Resist the Adsorption of Proteins and the Adhesion of Bacteria, Langmuir 1225, 1226, Vol. 17. No. 4, 2001	
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